

U.S. Department of Commerce, Patent and Trademark Office				Docket No. <b>AM-3245</b>				
				Serial No.: <b>09/276,376</b>				
O I P E LIST OF RELEVANT ART CITED BY APPLICANT				Applicant: <b>Holman (Raymond) Hung et al.</b>				
MAY 15 2003 (Use several sheets if necessary)				Filing Date: <b>March 25, 1999</b>				
				Group: <b>1763</b>				
<b>U.S. PATENT DOCUMENTS</b>								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>Au</i>	AA	5,366,590	11/22/94	Kadomura	156	662		
<i>Au</i>	AB	6,028,362	02/22/00	Omura	257	774		
<i>Au</i>	AC	6,365,060	04/02/02	Nagaseki et al.	216	59		
<i>AD</i>								
<i>AE</i>							<i>RECEIVED</i>	
<i>AE</i>							<i>MAY 16 2003</i>	
<i>AG</i>							<i>TC 700</i>	
<i>AH</i>								
<b>FOREIGN PATENT DOCUMENTS (Translation)</b>								
		Document Number	Date	Country	Class	Subclass	Yes	No
<i>AL</i>	AL	8-31802	02/02/96	JP			Abstract	
<i>AM</i>	AM	9-312350	02/12/97	JP			Abstract	
<i>AN</i>	AN	8-165584	06/25/96	JP			Abstract	
<i>AO</i>	AO	10-313009	11/24/98	JP			Abstract	
<i>AP</i>	AP	6-275568	09/30/94	JP			Abstract	
<b>OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)</b>								
<i>AR</i>	AR							
<i>AS</i>	AS							
<i>AT</i>	AT							
Examiner	<i>Mc Ola 7/1/04</i>	Date Considered						
*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with your communication to applicant.								

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				Group:	1763			
U.S. PATENT DOCUMENTS								
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate	
<i>Aao</i>	AA	6,117,786	09/12/00	Khajehnouri et al.	438	700		
<i>Reed</i>	AB	6,297,163	10/02/01	Zhu et al.	438	707		
	AC							
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Examiner	<i>Mr. Oba</i>	Date Considered	<i>7/2/2004</i>					
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